## REPLACEMENT SHEET

Docket No.: APPM/005730/TCG/WCVD/AG

App No.: 10/023,125

Docket No.: APPM/005730/TCG/N/CVD/A
Inventors: JONG HYUN YOO, et al.
Title: PULSE NUCLEATION ENHANCED NUCLEATION TECHNIQUE FOR
IMPROVED STEP COVERAGE AND BETTER GAP FILL FOR WCVD PROCESS

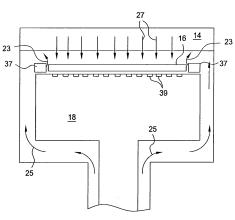


FIG. 2

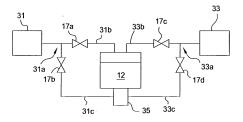


FIG. 3

 $_{\perp}$